



**ELECTRONIC COPY**

LG666407982  
Report verification at igi.org



November 20, 2024  
IGI Report Number **LG666407982**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **MARQUISE BRILLIANT**  
Measurements **12.24 X 6.55 X 4.19 MM**

**GRADING RESULTS**

Carat Weight **1.97 CARAT**  
Color Grade **F**  
Clarity Grade **VS 1**

November 20, 2024  
IGI Report Number **LG666407982**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **MARQUISE BRILLIANT**  
Measurements **12.24 X 6.55 X 4.19 MM**

**GRADING RESULTS**

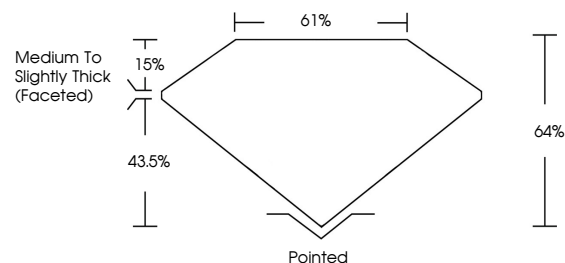
Carat Weight **1.97 CARAT**  
Color Grade **F**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **LG666407982**

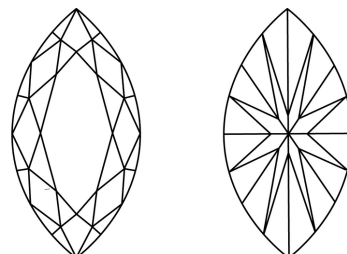
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

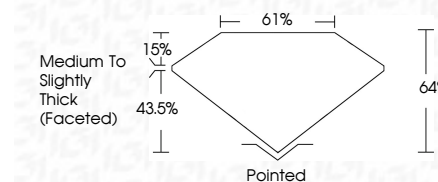
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **LG666407982**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



November 20, 2024  
IGI Report No **LG666407982**  
**MARQUISE BRILLIANT**  
12.24 X 6.55 X 4.19 MM  
Carat Weight **1.97 CARAT**  
Color Grade **F**  
Clarity Grade **VS 1**  
Depth **64%**  
Table **61%**  
Girdle **Medium to Slightly Thick (Faceted)**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **LG666407982**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa